

Form PTO-1449  <b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  <i>(Use several sheets if necessary)</i>			Docket Number (Optional) <b>3403.4US (97-0758.04/US)</b>		Application Number <b>N t yet assigned</b>	
			Applicant <b>Gealy et al.</b>			
			Filing Date <b>July 22, 2003</b>		Group Art Unit <b>Unknown</b>	

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
PEP	5,382,533	01/1995	Ahmad et al.			
PEP	5,416,045	05/1995	Kauffman et al.			
PEP	5,479,955	01/1996	Roodvoets et al.			
PEP	5,569,936	10/1996	Zhang et al.			
PEP	5,595,923	01//1997	Zhang et al.			
PEP	5,595,944	01/1997	Zhang et al.			
PEP	5,606,179	02/1997	Yamazaki et al.			
PEP	5,624,865	04/1997	Schuegraf et al.			
PEP	5,646,075	07/1997	Thakur et al.			
PEP	5,646,424	07/1997	Zhang et al.			
PEP	5,840,600	11/1998	Yamazaki et al.			
PEP	6,291,364	09/2001	Gealy et al.			
PEP	6,423,649	07/2002	Gealy et al.			
PEP	6,596,651	07/2003	Gealey et al.			


  

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS		(Including Author, Title, Date, Pertinent Pages, Etc.)
PEP		Nitrated Oxides, Silicon Processing for the VLSI Era - Volume III, Pages 648-661.

EXAMINER 	DATE CONSIDERED <b>9/13/04</b>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance. Include copy of this form with next communication to the applicant.